

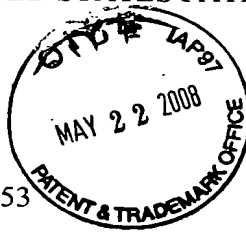
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Junichi UENO

Application No.: 10/549,453

Filed: September 14, 2005



Group Art Unit: 3723

Examiner: R. ROSE

Docket No.: 125333

For: WAFER-HOLDING CARRIER, DOUBLE-SIDE POLISHING APPARATUS USING THE
SAME, AND DOUBLE-SIDE POLISHING METHOD OF WAFER

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- ☒ 2. An English language Abstract of one or more non-English language reference is attached.
- ☒ 3. A computer-generated English language translation of one or more Japanese Patent Publication cited herein has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy.

Respectfully submitted,

William P. Berridge
Registration No. 30,024

Benjamin S. Prebyl
Registration No. 60,256

WPB:BSP/amw

Date: May 22, 2008

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

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